Search Notes

Applica	tion/Control	No.

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Art Üi 2624

OGAWA, HIDEHIKO

Applicant(s)/Patent under Reexamination

Thomas D. Lee

SEARCHED				
Class	Subclass	Date	Examiner	
358	1.15, 402, 440	6/7/2005	TDL	
379	100.01	6/7/2005	TDL	
379	100.08	6/7/2005	TDL	
379	100.13	6/7/2005	TDL	
379	100.17	6/7/2005	TDL	
updated		9/15/2005	TDL	
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INTERFERENCE SEARCHED				
Class	Subclass	Date	Examiner	
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SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
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